

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of :

Toshio KODAMA et al. :

Appln No. 10/520,982 : Group Art Unit - 2881

Filed: March 14, 2005 : Examiner- Jack I. Berman

For: ION BEAM APPARATUS, AND :

ION BEAM PROCESSING

METHOD, AND HOLDER MEMBER : Docket No. S005-5433(PCT)

Mail Stop ISSUE FEE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF DRAWING INCONSISTENCY WITH SPECIFICATION

S I R:

In response to the Notice Of Drawing Inconsistency With Specification ("Notice") mailed August 7, 2007, applicants amend their application as follows:

ADDITIONAL FEE:

No additional fee is believed required in connection with this response; however, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 4